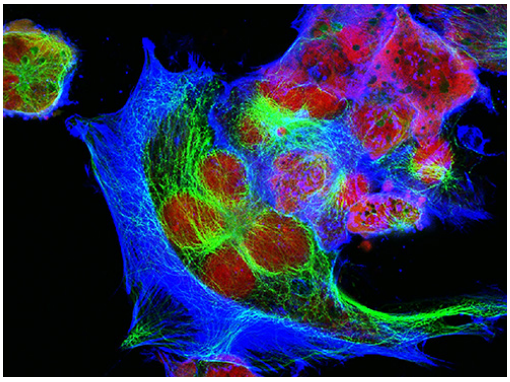
WHY YOU SHOULD USE TOP HAT ILLUMINATION IN WIDE-FIELD FLUORESCENCE MICROSCOPY



Introduction

Wide-field fluorescence microscopy is an indispensable tool in the fields of biological, biomedical, and materials research, enabling scientists to visualize cellular structures, molecular interactions, and dynamic processes at a high resolution. However, the technique's success relies heavily on the quality of illumination, which directly affects the accuracy, sensitivity, and reproducibility of the acquired data. As fluorescence microscopy continues to evolve, optimizing the illumination profile has emerged as one crucial aspect in enhancing the overall performance of these systems and advancing scientific discovery.

Lasers have become increasingly popular as an illumination source in wide-field fluorescence microscopy due to their exceptional properties, such as high energy concentration, coherence, and monochromaticity. However, the laser source comes with its own set of challenges, particularly related to the intensity profile of the laser beam.

In this whitepaper we want to discuss how wide-field fluorescence can benefit from a more uniform illumination and how you can implement such a solution in your wide-field fluorescence microscope.

Basic Fluorescence illumination - The Gaussian laser beam

The natural intensity distribution of laser sources are Gaussian beam profiles, as it is a direct consequence of the physics involved in generating laser radiation. Because of its high energy concentration at the central peak, this profile can be advantageous for specific applications. E.g. fluorescence correlation spectroscopy or laser scanning microscopy require small laser spots for high signal-to-noise ratios and pinpoint precision.

But it also presents challenges for many industrial, scientific, and life science applications, particularly in wide-field fluorescence microscopy. Because of the non-uniform intensity distribution within the Gaussian laser beam the illumination across the field of view is uneven and a correction for this may necessitate extensive post-processing and analysis. This can be both time-consuming and lead to computational artifacts limiting the quality and the overall efficiency of fluorescence microscopy experiments.

Additionally, the uneven Gaussian illumination exacerbates problems related to photobleaching and phototoxicity. Its high intensity at the center of the beam can cause rapid degradation of fluorophores and adversely affect the health and viability of biological samples. This issue is particularly relevant for live cell imaging and other sensitive applications, where maintaining sample integrity is of paramount importance.

In conclusion, while Gaussian illumination offers certain benefits in some types of fluorescence microscopy, its challenges make it less than ideal for wide-field applications. Thus, for wide-field fluorescence microscopy, uniform types of illumination offer a more beneficial alternative.

Beyond Gaussian illumination - Top hat beam profile in fluorescence microscopy

The top hat illumination profile has emerged as a highly advantageous alternative to Gaussian illumination for wide-field fluorescence microscopy, addressing many of the challenges associated with non-uniform intensity distributions. In contrast to Gaussian profiles, top hat illumination provides a consistent and uniform intensity distribution across the entire field of view, which brings forth numerous benefits for various applications in wide-field fluorescence microscopy.

asphericon GmbH
sales@asphericon.com | +49 3641 3100 500

asphericon, Inc.
info@asphericon-inc.com | +1 941 564 0890

asphericon s.r.o.
sales@asphericon.cz | +420 488 100 300

www.asphericon.com

One of the most significant advantages of top hat illumination is the reduction of artifacts and the improvement of image contrast. By ensuring that all regions within the field of view receive equal illumination, top hat profiles minimize the occurrence of uneven brightness and shading artifacts, which can complicate data interpretation and analysis. This uniformity results in higher quality images with improved contrast, enabling researchers to draw more accurate and reliable conclusions from their data.

In addition to enhancing image quality, top hat illumination also mitigates issues related to photobleaching and phototoxicity. The even distribution of light intensity ensures that fluorophores do not experience rapid degradation due to localized high-intensity regions, as seen in Gaussian profiles. This preservation of fluorophores leads to more consistent and reproducible results. Furthermore, the reduced phototoxicity helps maintain the health and viability of biological samples, particularly in live cell imaging and other sensitive applications where sample integrity is crucial.

Top hat illumination also contributes to increased experimental efficiency. The uniform light distribution minimizes the need for extensive image processing and analysis to correct for uneven illumination, reducing both the time and computational resources required. Faster data acquisition and analysis ultimately accelerate the pace of discovery in the research process.

Ways to create a top hat profile

Creating a top hat profile for wide-field fluorescence illumination involves modifying the intensity distribution of the laser beam to achieve a uniform and even distribution of light across the entire field of view. Several techniques have been developed to achieve this, including truncating the beam, using spatial light modulators (SLMs), and employing beam shaping optics with specifically designed aspheric lenses. Each method comes with its own benefits and challenges, as discussed below.

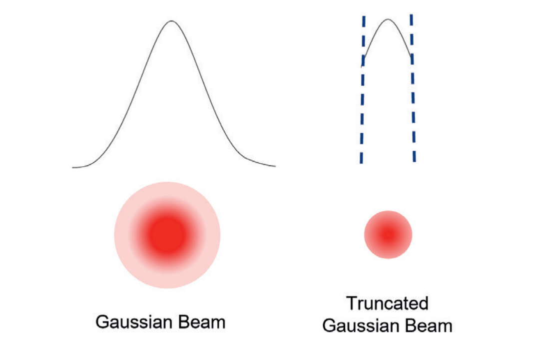


Fig. 1: Schematic illustration of the generation of top hat profiles by truncation

Truncating the beam

Truncating the Gaussian beam involves blocking the peripheral regions of the beam, leaving only the central region with the highest intensity (see Fig. 1). By limiting the spatial extent of the beam, this method creates a quasi-flat intensity distribution, mimicking a top hat profile. While truncating the beam is relatively simple and cost-effective, it has some drawbacks. The resulting profile may still exhibit some residual Gaussian characteristics, leading to less-than-ideal uniformity. Additionally, the inserted aperture can create diffraction rings in the sample plane under certain circumstances. To prevent this, the aperture plane is mapped into the sample plane, increasing the complexity of the optical setup. However, the most significant challenge is the loss of power due to the blocking of a portion of the beam. This reduces the overall efficiency of the illumination system and especially in single molecule fluorescence microscopy, the necessary light sources can become quite costly. As a result, loosing photons hurts and makes truncating the beam a sub-optimum solution.

Spatial light modulators (SLMs)

SLMs are devices that can modify the phase and amplitude of incoming light, allowing for precise control over the resulting beam profile (see Fig. 2). By tailoring the phase and amplitude distribution across the SLM, a Gaussian beam can be transformed into a top hat profile. This offers high flexibility and precision in beam shaping, making them suitable for a wide range of applications.

Additionally, SLMs are typically designed for one specific wavelength and need to be re-calibrated if you want to use them under changed conditions. This requires experience and sophisticated measurement equipment limiting the tasks to tech-savvy laboratories.

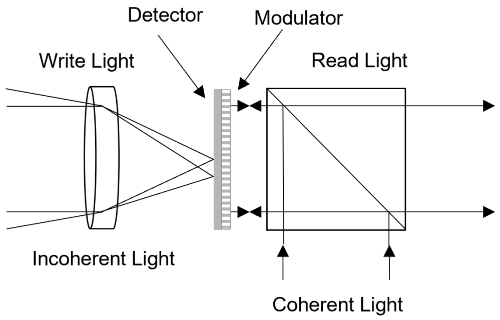


Fig. 2: Schematic working principle of a SLM

Beam shaping optics

Beam shaping optics can be used to transform Gaussian beams into top hat profiles (see Fig. 3). Aspheric beam shaping systems have lenses with a non-spherical surface profile that can redistribute the incoming light intensity to create a uniform output beam. These lenses offer excellent optical quality and can achieve highly uniform top hat profiles with minimal optical losses. Furthermore, aspheric lenses are typically compact and compatible with a variety of microscopy systems.

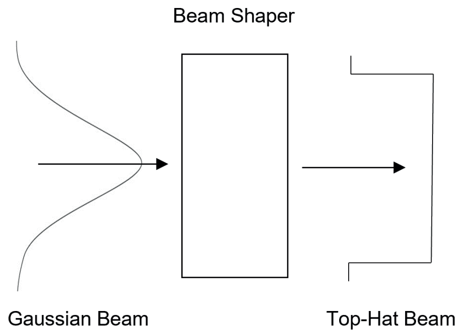


Fig. 3: Schematic working principle of a beam shaper

And they can be designed for a wide spectral range making them an ideal choice for multi-channel fluorescence experiments.

Although custom-designed aspheric lenses can be more expensive than truncating the Gaussian beam profile, they are still significantly cheaper compared to SLMs and a good choice, especially, for systems requiring specific performance parameters.

However, one minor challenge associated with aspheric lenses is their sensitivity to alignment. A proper positioning is crucial for achieving the desired beam profile. Here, the right tools for the alignment significantly improve the ease of integration and optimize the optical performance.

In light of these challenges, optics manufacturers combine such optical elements to integrated solutions for beam shaping like e.g., the asphericon a|TopShape leveraging their expertise and advanced engineering. This way, the researcher is offered a more reliable and user-friendly way for achieving top hat profiles in wide-field fluorescence microscopy while minimizing the difficulties associated with alignment, input beam diameter dependence, and beam profile transformations.

Application of top hat illuminations for advanced imaging techniques

Top hat illumination has been shown to provide significant benefits for advanced imaging techniques such as super-resolution microscopy and total internal reflection fluorescence (TIRF) microscopy, improving the overall performance and reliability of these methods.

Super-resolution microscopy

Super-resolution microscopy encompasses a group of techniques that overcome the diffraction limit of conventional optical microscopy, allowing researchers to visualize structures and molecular interactions at the nanoscale.

asphericon GmbH
sales@asphericon.com | +49 3641 3100 500

asphericon, Inc.
info@asphericon-inc.com | +1 941 564 0890

asphericon s.r.o.
sales@asphericon.cz | +420 488 100 300

www.asphericon.com

In super-resolution microscopy, uniform illumination is of paramount importance, as it ensures consistent and reliable localization of fluorophores throughout the entire field of view. Top hat illumination, with its even distribution of light intensity, delivers this essential uniformity. By providing optimal illumination across the sample, top hat profiles improve localization precision and enhance the overall resolution of super-resolution microscopy techniques, such as stochastic optical reconstruction microscopy (STORM), photoactivated localization microscopy (PALM), and structured illumination microscopy (SIM).

Total internal reflection fluorescence (TIRF) microscopy

TIRF microscopy is a powerful technique for selectively imaging the vicinity of the cell membrane or other interfaces with high signal-to-noise ratios. It relies on the evanescent wave created by total internal reflection, which penetrates only a short distance into the sample, thus enabling selective excitation of fluorophores close to the interface. In TIRF microscopy, even and consistent illumination is crucial for generating a uniform evanescent field, ensuring that all fluorophores within the penetration depth receive equal excitation. Top hat illumination, with its uniform intensity distribution, greatly benefits TIRF microscopy by generating a consistent evanescent field. This consistency results in more accurate and reliable measurements of molecular interactions and dynamics occurring near the cell membrane or other interfaces, allowing researchers to gain deeper insights into the underlying biological processes.

Conclusion

In conclusion, adopting a top hat profile for wide-field illumination in super-resolution fluorescence microscopy provides significant advantages over traditional Gaussian illumination, including improvements in image quality, sample integrity, and experimental efficiency. Users of wide-field fluorescence microscopes with flat top illumination will benefit from these enhancements, which ultimately contribute to more accurate and reliable data acquisition and analysis. Aspheric beam shaping solutions offer an excellent choice for achieving top hat profiles across a wide range of microscopy applications, such as super-resolution and TIRF microscopy and provide exceptional optical quality and uniform illumination. When using integrated application-specific solutions like a TopShape for the beam shaping, the challenges of integration and operation can be reduced. Hence, by incorporating such solutions into their microscopy systems, scientists can optimize their experiments and focus on their research endeavors, without the need for extensive adjustments and customizations. The numerous benefits of top hat illumination profiles emphasize the importance of optimizing the illumination source in fluorescence microscopy to unlock the full potential of this technique and push the boundaries of scientific discovery.

asphericon GmbH
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asphericon, Inc.
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www.asphericon.com